



RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2800

PATENT APPLICATION  
Docket No. 5484-048  
Client No. PX828-US/SSD

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Byung-Sup Shim and Young-Ho Kim

Serial No. 09/305,240 Examiner: Nadav, Ori

Filed: May 4, 1999 Art Unit: 2811

For: OPEN DRAIN INPUT/OUTPUT STRUCTURE AND  
MANUFACTURING METHOD THEREOF IN SEMICONDUCTOR  
DEVICE

Confirmation No. 1838

MAIL STOP AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116**

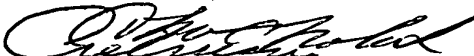
Responsive to the Final Office Action, Paper No. 30, dated October 7, 2003, please  
amend the application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of  
this paper.

**Remarks/Arguments** begin on page 7 of this paper.

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Adrienne Chocholak